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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit:

Serial No.: **10/576,193**

Examiner: **Not yet assigned**

Filed: **April 17, 2006**

P.T.O. Confirmation No.: **8608**

For: **METHOD OF FORMING LUSTER COATING FILM**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 17, 2006

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached, together with a copy of an International Search Report.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: International Search Report
PTO-1449
References (11)



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 060321	Serial No. 10/576,193
Applicant(s): FUJIEDA, Tsukasa		
	Filing Date: April 17, 2006	Group Art Unit: Not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclas- s	Filing Date (If appropriate)
	AA					
	AB					

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
	AC	JP 2001-149857 A	6/05/01	Japan	Abstract only
	AD	JP 6-51160 B	7/06/94	Japan	Abstract only
	AE	JP 9-141195 A	6/03/97	Japan	Abstract only
	AF	JP 2002-273333 A	9/24/02	Japan	Abstract only
	AG	JP 9-1050 A	1/07/97	Japan	Abstract only
	AH	JP 61-74679 A	4/16/86	Japan	Abstract only
	AI	JP 2002-86057 A	3/26/02	Japan	Abstract only
	AJ	JP 2002-102798 A	4/09/02	Japan	Abstract only
	AK	JP 2001-347223 A	12/18/01	Japan	Abstract only
	AL	JP 11-300239 A	11/02/99	Japan	Abstract only
	AM	JP 62-33578 A	2/13/87	Japan	Abstract only

OTHER DOCUMENTS

	AN	
Examiner		Date Considered



List of publications

	Non-English language documents Foreign patent : country/number/publication date Publication : author/place/title/page/publication date	English version search report	Concise state- ment	English trans- lation	English abstract	First cited in foreign application Yes/No/-* Check after >3 months from filing/ national entry
		Yes/No	Yes/No	Yes/No Partial	Yes/No	
(1)	JP 2001-149857 A	Yes	No	No	Yes	--
(2)	JP 6-51160 B	Yes	No	No	Yes	--
(3)	JP 9-141195 A	Yes	No	No	Yes	--
(4)	JP 2002-273333 A	Yes	Yes	No	Yes	--
(5)	JP 9-1050 A	Yes	No	No	Yes	--
(6)	JP 61-74679 A	Yes	No	No	Yes	--
(7)	JP 2002-86057 A	Yes	No	No	Yes	--
(8)	JP 2002-102798 A	Yes	No	No	Yes	--
(9)	JP 2001-347223 A	Yes	No	No	Yes	--
(10)	JP 11-300239 A	Yes	No	No	Yes	--
(11)	JP 62-33578 A	Yes	No	No	Yes	--

- ◆ Please note that publications (1)-(11) were cited in the International Search Report mailed on February 1, 2005 during the international phase of the instant PCT application.
- ◆ Please note that publication (4) was a document cited in the specification.
- We are also note that publication _____ corresponds to publication _____.



Concise statement of relevancy

Japanese Unexamined Patent Publication No.

2002-273333 discloses a method of forming a luster coating film,
5 in which a luster base coating is formed on a substrate in two stages, followed by forming a clear coating, the thickness ratio of the base coating composition applied in the first stage to that applied in the second stage being 2/1 to 4/1. This method can prevent unevenness in the luster of luster coating films.

10 However, especially when an aqueous luster base coating composition is used, the above method is likely to result in insufficient orientation of the flaky luster pigment used, and is not capable of forming a luster coating film with a highly dense texture and high flip-flop property.

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